



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Farnworth et al.

Serial No.: 09/589,841

Filed: June 8, 2000

For: STEROLITHOGRAPHIC METHODS
FOR FORMING A PROTECTIVE LAYER
ON A SEMICONDUCTOR DEVICE
SUBSTRATE AND SUBSTRATES
INCLUDING PROTECTIVE LAYERS SO
FORMED

Examiner: G. Lee

Group Art Unit: 2825

Attorney Docket No.: 3923US (99-0033)

NOTICE OF EXPRESS MAILING

Express Mail Mailing Label Number: EL740518628

Date of Deposit with USPS: January 23, 2002

Person making Deposit: Orlena Howell

TECHNOLOGY CENTER 2800

FEB - 4, 2002

RECEIVED

11/A Amdt
2/9/02
A. Welch

AMENDMENT

Commissioner for Patents
Box Non Fee Amendment
Washington, D.C. 20231

Sir:

This Amendment is being filed in response to the Office Action mailed on October 24, 2001, the three-month shortened statutory period for response to which expires on January 24, 2002.

[Handwritten mark]